

DOCKET NO.: 242866US0



IFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:

Nobuhiko IZUTA, et al.

SERIAL NO: 10/661,662

GROUP: 1765

FILED: September 15, 2003

EXAMINER: S. AHMED

RCE FILED: July 17, 2006

FOR: REGENERATION PROCESS OF ETCHING SOLUTION, ETCHING  
PROCESS, AND ETCHING SYSTEM

**LETTER**

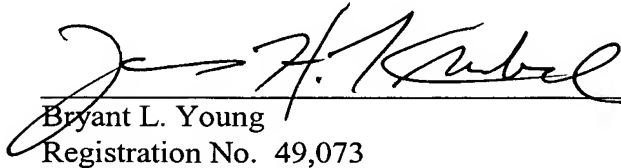
Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith is a Chinese Office Action with English translation for the Examiner's consideration.

Respectfully Submitted,

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